

PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1
 Stylesheet Version v1.2

EPAS ID: PAT4321452

SUBMISSION TYPE:	NEW ASSIGNMENT	
NATURE OF CONVEYANCE:	ASSIGNMENT	
CONVEYING PARTY DATA		
	Name	Execution Date
	OSAKA UNIVERSITY	02/25/2017
RECEIVING PARTY DATA		
Name:	PI-CRYSTAL INC.	
Street Address:	7-38, NISHIMIYAHARA 2-CHOME, YODOGAWA-KU	
City:	OSAKA-SHI, OSAKA	
State/Country:	JAPAN	
Postal Code:	532-0004	
PROPERTY NUMBERS Total: 3		
Property Type	Number	
Application Number:	13499743	
Application Number:	14237055	
Application Number:	14786835	
CORRESPONDENCE DATA		
Fax Number:	(612)455-3801	
<i>Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.</i>		
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Email:	pkerkhove@hsml.com	
Correspondent Name:	HAMRE, SCHUMANN, MUELLER & LARSON, P.C.	
Address Line 1:	45 SOUTH SEVENTH STREET	
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Address Line 4:	MINNEAPOLIS, MINNESOTA 55402	
ATTORNEY DOCKET NUMBER:	10873.2538; 2594; 2655	
NAME OF SUBMITTER:	DOUGLAS P. MUELLER	
SIGNATURE:	/dpmueller/	
DATE SIGNED:	03/16/2017	
Total Attachments: 2		
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10873.2538USWO
10873.2594USWO
10873.2655USWO

CORPORATION TO CORPORATION ASSIGNMENT

WHEREAS, OSAKA UNIVERSITY, a corporation organized under the laws of the country of Japan and having an office and place of business at 1-1, Yamadaoka, Suita-shi, Osaka 565-0871 Japan (hereinafter referred to as the "UNDERSIGNED"), has acquired by assignment three inventions for which applications for United States Letters Patents were filed, the first being filed on April 2, 2012 under Serial No. 13/499743, now issued Patent No. 8,921,152, entitled METHOD FOR MANUFACTURING ORGANIC SEMICONDUCTOR FILM, AND ORGANIC SEMICONDUCTOR FILM ARRAY; the second being filed on February 4, 2014 under Serial No. 14/237055, now issued Patent No. 9,153,789, entitled TRANSISTOR WITH SOURCE/DRAIN ELECTRODES ON PEDESTALS AND ORGANIC SEMICONDUCTOR ON SOURCE/DRAIN ELECTRODES AND METHOD FOR MANUFACTURING SAME; and the third being filed on October 23, 2015 under Serial No. 14/786835, entitled ORGANIC SEMICONDUCTOR THIN FILM PRODUCTION METHOD.

AND WHEREAS, PI-CRYSTAL INC., a corporation organized under the laws of the country of Japan and having an office and place of business at 7-38, Nishimiyahara 2-chome, Yodogawa-ku, Osaka-shi, Osaka 532-0004 Japan (hereinafter referred to as "ASSIGNEE"), wishes to acquire the right, title and interest in and to said U.S. Letters Patents obtained therefor;

NOW, THEREFORE, for and in consideration of the sum of One Dollar and other good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged,

the UNDERSIGNED hereby sells, assigns and transfers to the above ASSIGNEE, its successors and assigns, the right, title and interest in the United States in and to the inventions disclosed in the aforesaid applications, and all reissues or extensions of such patents and the UNDERSIGNED hereby authorizes and requests the Commissioner of Patents to issue any and all United States Letters Patents for the aforesaid inventions to the ASSIGNEE of the right, title and interest in and to the same, for the use of the ASSIGNEE, its successors and assigns.

THE UNDERSIGNED represents and agrees with said ASSIGNEE, its successors and assigns, that no assignment, grant, mortgage, license or other agreement affecting the rights and property herein conveyed has been or will be made to others by the UNDERSIGNED, and that full right to convey the same as herein expressed is possessed by the UNDERSIGNED.

IN TESTIMONY WHEREOF, the UNDERSIGNED have hereunto set its hand on the date indicated below.

Date Feb. 25, 2017

By: 
Shojiro NISHIO

Title: President, OSAKA UNIVERSITY